Figure 1. HV-CVD setup schematic and precursor flux simulation in a combinatorial mode.
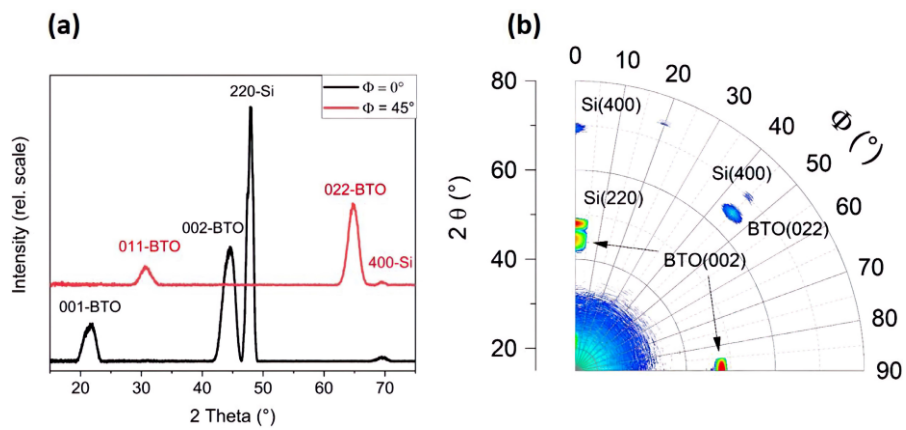

Figure 2. XRD texture analysis of BaTiO$_3$ on SrTiO$_3$-buffered Si, reproduced from Borzì et al, Materialia, 2020.